

RECEIVED  
CENTRAL FAX CENTER

SEP 22 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:	10/707,388	Conf. No.:	1387
Filing Date:	12/10/2003	Art Unit:	2891
Applicant:	Divakaruni et al.	Examiner:	Fulk, Steven J.
Title:	SILICIDE RESISTOR IN BEOL LAYER OF SEMICONDUCTOR DEVICE AND METHOD	Docket No.:	FIS920030274 (IBMF-0032)

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 571-273-8300

Transmitted herewith is:

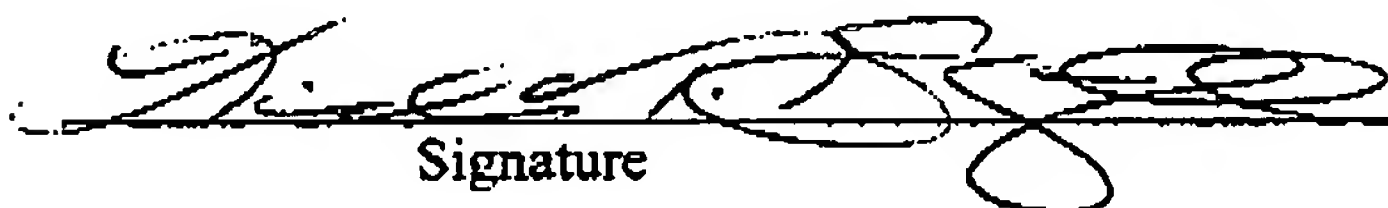
Amendment in 07 pages

in the above identified application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below.

Linda T. Sagarese  
(Person transmitting this correspondence)

	September 22, 2006
Signature	Date

If you receive this correspondence in error or do not receive the entire transmission, please notify us at (518) 449-0044.

**RECEIVED**  
**CENTRAL FAX CENTER**

**SEP 22 2006**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In Re Application of:** Divakaruni et al.

**Conf. No.:** 1387

**Serial No.:** 10/707,388

**Art Unit:** 2891

**Filed:** 12/10/2003

**Dkt. #:** FIS920030274US1 (IBMF-0032)

**Title:** SILICIDE RESISTOR IN BEOL  
LAYER OF SEMICONDUCTOR  
DEVICE AND METHOD

**Examiner:** Fulk, Steven J.

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

**I. INTRODUCTORY COMMENTS:**

In response to the Office Action of June 30, 2006, please amend the above-referenced patent application as follows: